Application No.	Applicant(s)		
09/711.905	ABE, SHINYA		
Examiner	Art Unit		
Kim-Kwok CHU	2653		
OR REMAINS) CLOSED in or other appropriate comm	ith the correspondence address this application. If not included unication will be mailed in due co	urse. THIS	
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* Certified copies not received:  Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.			
5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.			
Amendment / Comment or	r in the Office action of he drawings in the front (not the ba	nck) of	
7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.			
6. Interview S Paper No. ), 7. Examiner's	ummary (PTO-413), /Mail Date Amendment/Comment Statement of Reasons for Allowa	·	
	Examiner  Kim-Kwok CHU  Its on the cover sheet w. DR REMAINS) CLOSED in other appropriate commits. This application is and MPEP 1308.  Its 2004.  Its 35 U.S.C. § 119(a)-(d)  It is communication to file in this communication to file in this application.  It is communication to file in this application.	ABE, SHINYA  ART Unit  Kim-Kwok CHU  2653  ARE MAINS) CLOSED in this application. If not included in other appropriate communication will be mailed in due constituted and MPEP 1308.  18/2004.  Benumbered as 1-24 respectively.  Ininer.  Been received.  Deen received in Application No  Juments have been received in this national stage application.  If this communication to file a reply complying with the requirence.  Bed. Note the attached EXAMINER'S AMENDMENT or NOTe reason(s) why the oath or declaration is deficient.  Be submitted.  In's Patent Drawing Review ( PTO-948) attached  Amendment / Comment or in the Office action of  4(c)) should be written on the drawings in the front (not the base header according to 37 CFR 1.121(d).  It of BIOLOGICAL MATERIAL must be submitted. Not DR THE DEPOSIT OF BIOLOGICAL MATERIAL.  5. Notice of Informal Patent Application (PTO-16.   Interview Summary (PTO-413), Paper No./Mail Date	

## Allowable Subject Matter

- 1. Claims 1-5, 7-18 and 20-26 are allowable over prior art.
- 2. The following is an Examiner's statement of reasons for the indication of allowable subject matter based on Applicant's Amendment filed on August 18, 2004.

As in claims 1, 9, 14 and 22, the prior art of record fails to teach or fairly suggest a feedback control having the following features:

(a) the focusing control of the objective lens is executed to position a focal point of the objective lens a predetermined fine distance which is smaller than a film thickness of the photosensitive material film within the photosensitive material film relative to a surface of the photosensitive material film.

As in claims 5, 13, 18, 25 and 26 the prior art of record fails to teach or fairly suggest a feedback control having the following features:

- (a) the feedback control is performed using different light whose wavelength is longer than that of the recording light such that a distance between the objective lens and the recording medium remains constant;
- (b) a discrepancy of the distance between the objective lens and the recording medium from a desirable distance is

detected using reflected light which is generated as the recording medium reflects the recording light; and

(c) a control target position for the feedback control is corrected based on a detected discrepancy of the distance between the objective lens and the recording medium from a desirable distance such that the distance between the objective lens and the recording medium becomes the desirable distance.

As in claims 7 and 8, the prior art of record fails to teach or fairly suggest a method of detecting a deviation of a focal point position having the following features:

- (a) the intensity distribution of the reflected light is an intensity distribution of a spot of the reflected light which is projected on a light receiving surface which is arranged confocal with respect to the recording medium; and
- (b) based on an intensity at the center inside the spot and a distance between the center of the spot and a point at which an intensity of a diffraction ring is maximum, the discrepancy of the distance between the objective lens and the recording medium from the desirable distance is detected.

As in claims 20 and 21, the prior art of record fails to teach or fairly suggest a focal point deviation detecting means having the following features:

(a) the intensity distribution of the reflected light is an intensity distribution of a spot of the reflected light which is

projected on a light receiving surface is detected as the intensity distribution of the reflected light; and

(b) a judgment means judges an intensity at the center inside the spot and a distance between the center of the spot and a point at which an intensity of a diffraction ring of the spot to thereby detect the discrepancy of the distance between the objective lens and the recording medium from a desirable distance.

The features indicated above, in combination with the other elements of the claims, are not anticipated by, nor made obvious over the prior art of record.

3. Any comments considered necessary by applicant must be submitted no later than the payment of the Issue Fee and, to avoid processing delays, should preferably accompany the Issue Fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## Conclusion

4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Hoshino et al. (5,740,138) is pertinent because Hoshino teaches a second laser with a longer wavelength as a rough focusing adjusting means.

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5. Any response to this action should be mailed to:

Commissioner of Patents and Trademarks Washington, D.C. 20231 Or faxed to:

(703) 872-9306 (for formal communications intended for entry. Or:

(703) 746-6909, (for informal or draft communications, please label "PROPOSED" or "DRAFT")

Hand-delivered responses should be brought to Crystal Park II, 2021 Crystal Drive, Arlington. VA., Sixth Floor (Receptionist).

Any inquiry of a general nature or relating to the status of this application should be directed to the Group receptionist whose telephone number is (703) 305-4700.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kim CHU whose telephone number is (703) 305-3032 between 9:30 am to 6:00 pm, Monday to Friday.

(4 11/2/04

Kim-Kwok CHU Examiner AU2653 November 22, 2004

(703) 305-3032

WILLIAM KORZUCH SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2600